



**ELECTRONIC COPY**

LG800613076  
Report verification at igi.org



May 20, 2026

IGI Report Number **LG800613076**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**

Measurements **8.63 X 6.22 X 4.11 MM**

**GRADING RESULTS**

Carat Weight **2.00 CARATS**

Color Grade **D**

Clarity Grade **VS 1**

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Shape and Cutting Style **CUT CORNERED RECTANGULAR  
MODIFIED BRILLIANT**

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**GRADING RESULTS**

Carat Weight **2.00 CARATS**

Color Grade **D**

Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

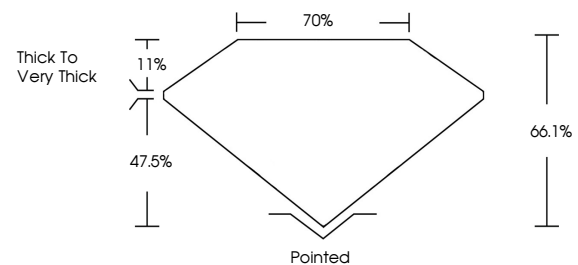
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG800613076**

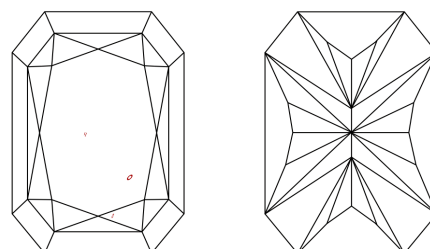
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

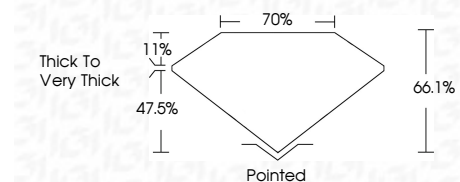
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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IGI Report No LG800613076  
CUT CORNERED RECT. MODIFIED BRILLIANT  
8.63 X 6.22 X 4.11 MM  
2.00 CARATS  
D  
Color Grade  
Clarity Grade VS 1  
Depth 66.1%  
Table 70%  
Girdle Thick to Very Thick  
Culet Pointed  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
Inscription(s) IGI LG800613076  
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Type IIa